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AMENDMENT AND RESPONSE TO OFFICE ACTION

TO:

COMMISSIONER OF PATENTS AND TRADEMARKS

Washington, D.C. 20231

FROM:

Tung & Associates

838 West Long Lake Road - Suite 120

Bloomfield Hills, MI 48302

DATE:

8 April 2003

REF:

APPLICANT

Liang

SERIAL NO.

09/885,784

ART UNIT

2823

ATT'Y NO.

FILING DATE : 20 June 2001

EXAMINER .

: 67,200-327; TSMC 00-132

DIET D

: Julio J. Maldonado

TITLE

: Laminating Method for Forming Integrated Circuit

Microelectronic Fabrication

Sir:

In response to an office action mailed on 25 March 2003, please consider the following amendments and remarks pertaining to the above referenced application.

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with sufficient postage as first class mail in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231 on 2003.

Kathy Dixon